

Refine Search

Search Results -

Terms	Documents
semiconductor and (nanoscale same roughness).clms.	0

Database:

US Pre-Grant Publication Full-Text Database

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 EPO Abstracts Database
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 Derwent World Patents Index
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Search:

L7

Search History

 DATE: Monday, October 03, 2005 [Printable Copy](#) [Create Case](#)
Set Name Query

side by side

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result set

DB=PGPB; PLUR=YES; OP=ADJ

L7 semiconductor and (nanoscale same roughness).clms.

 0 L7

DB=JPAB; PLUR=YES; OP=ADJ

L6 semiconductor and (nanoscale same roughness)

 0 L6

DB=EPAB; PLUR=YES; OP=ADJ

L5 semiconductor and (nanoscale same roughness)

 0 L5

DB=USPT; PLUR=YES; OP=ADJ

L4 semiconductor and (nanoscale same roughness)

 27 L4

DB=PGPB; PLUR=YES; OP=ADJ

L3 semiconductor and (nanoscale same roughness)

 40 L3

DB=TDBD; PLUR=YES; OP=ADJ

L2 semiconductor and (nanoscale same roughness)

 1 L2

DB=DWPI; PLUR=YES; OP=ADJ

L1 semiconductor and (nanoscale same roughness)

 1 L1

END OF SEARCH HISTORY